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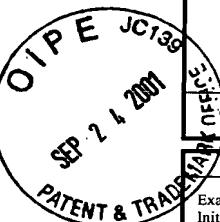
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/765,388
				Filing Date	January 22, 2001
				First Named Inventor	Nobuo SHIMAZU et al.
				Group Art Unit	2881
				Examiner Name	Unknown
				Attorney Docket Number	740107-140
Sheet	1	of	1		



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

PATENT CITATION - NON-PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
<i>JN</i>	/	LOW ENERGY ELECTRON-BEAM PROXIMITY PROJECTION LITHOGRAPHY: DISCOVERY OF MISSING LINK, TAKAO UTSUMI, J. VAC. SCI. TECHNOL. B 17(6), NOV./DEC. 1999, PP. 2897-2902	/
<i>DP</i>	/	HIGH THROUGHPUT SUBMICRON LITHOGRAPHY WITH ELECTRON BEAM PROXIMITY PRINTING, H. BOHLEN ET AL., SOLID STATE TECHNOLOGY, SEPTEMBER 1984, PP. 210-217	/

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